

# Kenji Amaya

## List of Publications by Year in descending order

Source: <https://exaly.com/author-pdf/9999013/publications.pdf>

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5  
papers

3  
citations

3311381

1  
h-index

3475538

1  
g-index

5  
all docs

5  
docs citations

5  
times ranked

3  
citing authors

#	ARTICLE	IF	CITATIONS
1	Numerical modeling method for UV imprint process simulation using thermoviscoelastic constitutive equations. <i>Journal of Vacuum Science and Technology B:Nanotechnology and Microelectronics</i> , 2019, 37, 062915.	1.2	2
2	Numerical analysis of pattern shape deformation in UV imprint considering thermal deformation with UV shrinkage and curing. <i>Journal of Vacuum Science and Technology B:Nanotechnology and Microelectronics</i> , 2021, 39, .	1.2	1
3	Development of Electrochemical Flow Cell System Programmable to Set Sample Concentration. <i>Hyomen Gijutsu/Journal of the Surface Finishing Society of Japan</i> , 2019, 70, 364-368.	0.2	0
4	Numerical Analysis of Pattern Shape Deformation in UV Imprint Due to Curing Shrinkage. <i>Journal of Photopolymer Science and Technology = [Fotoporima Konwakai Shi]</i> , 2020, 33, 245-250.	0.3	0
5	Development of Cathodic Protection Monitoring Method Using Data Assimilation. <i>Zairyo/Journal of the Society of Materials Science, Japan</i> , 2020, 69, 783-788.	0.2	0